



FORM PTO-1449	Docket Number (Optional) 006869USA	Application Number 10/659,902
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Applicant SOMEKH	
	Filing Date September 11, 2003	Group Art Unit 1753
7085		

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE
SHV	5	1	6	0	5	7	6	11/3/92	Robbins	216	60	
SHV	5	2	9	0	3	8	3	3/1/94	Koshimizu	156	345.25	
SHV	5	3	4	7	4	6	0	9/13/94	Gifford et al.	700	121	
SHV	5	7	2	8	2	5	3	3/17/98	Saito et al.	156	345.25	
SHV	5	8	7	1	6	5	8	2/16/99	Tao et al.	216	60	
SHV	5	9	8	0	7	6	7	11/9/99	Koshimizu et al.	216	60	
SHV	6	1	1	7	3	4	8	9/12/00	Peng et al.	216	60	
SHV	6	1	2	1	1	4	7	9/19/00	Daniel et al.	438	692	
SHV	6	1	9	0	9	2	7	2/20/01	Liu	438	8	
SHV	6	2	0	7	0	0	8	3/27/01	Kijima	216	59	
SHV	6	2	5	8	4	9	7	7/10/01	Kropp et al.	430	30	
SHV	6	2	6	5	3	1	6	7/24/01	Yoshida	438	700	
SHV	6	2	9	7	0	6	4	10/2/01	Koshimizu	438	9	
SHV	6	3	2	6	7	9	4	12/4/01	Lundquist et al.	324	678	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	Translation	
												YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

SHV	Li, et al. US 2001/0007772 pub. 7/12/01
SHV	Radzimski, Z. J., et al. "Optical emission spectroscopy of high density metal plasma formed during magnetron sputtering." J. Vac. Sci. Tech., B 15(2), Mar/Apr 1997; pp 202-208.

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.